

1762

## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:		) . Everniner: M. Bedgett		
TAKESHI SHISHIDO ET AL.		Examiner: M. Padgett  Group Art Unit: 1762		
Application No.: 09/822,191		)		
Filed	: April 2, 2001	· )		
For:	EXHAUST PROCESSING METHOD, PLASMA PROCESSING METHOD AND PLASMA PROCESSING APPARATUS	) : September 29, 2006		
<b>P.O.</b> 3	missioner for Patents Box 1450 andria, VA 22313-1450			
	AMENI	<u>OMENT</u>	•	
Sir:				
(a)	Introductory Comments		•	
	In response to the Office Action	n dated June 29, 2006, kindl	y amend the	
subje	ct application as follows.			
		I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on		
			September 29, 2006	
		(Date of Depo	OSIL)	
		Peter Saxon (Name of Attorney for Applicant)		
		Reder Attorne	September 29, 2006	
		Signature	Date of Signature	